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FILING or 371(c) DATE

03/29/2006

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P O. Box 1450 Alexandria, Virginia 22313-1450 www. upito gor

GROUP ART UNIT

1794

BIB DATA SHEET

SERIAL NUMBER

10/540,640

CONFIRMATION NO. 5378

ATTORNEY DOCKET NO. 2060.4

	RULE						
APPLICANTS Hiroyuki Fujimura, Tokyo, JAPAN; Roberto Massahiro Serikawa, Kanagawa, JAPAN; Naoki Ishikawa, Gunma, JAPAN; Takahiro Mishima, Hyogo, JAPAN;							
** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/21/2006							
Foreign Priority claimed 35 USC 119(a-d) conditions Verified and /ARCH		after COUNTRY		SHEETS RAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS	
TURNE		JAPAN		3	30	3	
ADDRESS							
HAMMER & HANF, PC 3125 PPRINGBANK LANE SUITE G CHARLOTTE, NC 28226 UNITED STATES							
TITLE							
Diamond film-forming silicon and its manufacturing method							
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_{FFF}				☐ 1.16 F	☐ 1.16 Fees (Filing)		
RECEIVED No				☐ 1.17 F	1.17 Fees (Processing Ext. of time)		
1530 No				-	1.18 Fees (Issue)		
1				<u> </u>	Other		
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CLASS

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